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Title of Invention	HDPCVD PROCESS AND METHOD FOR IMPROVING UNIFORMITY OF FILM THICKNESS	
Application Number :		
Date :		
First Named Applicant: Mr. Chien-Hung Lu		
Confirmation Number:		
Attorney Docket Number: 13622-US-PA		
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Submitted By:	Elec. Sign.	Sign. Capacity
Dr. Belinda Lee Registered Number: 46863	/Belinda Lee/	Agent

Documents being submitted:	Files
us-assignment	13622-usassn.xml us-assignment.xsl us-assignment.dtd 13622assignment01.tif 13622assignment02.tif
us-request	13622-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	13622-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
application-body	13622usf.xml application-body.dtd Image1.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogrk1.ent isogrk2.ent isogrk3.ent isogrk4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblk.dtd us-application-body.xsl wipo.ent
application-body-pdf-wrap	13622usf-pdf-wrap.xml
abstract-pdf	13622usf-abst.pdf
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Comments

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